

WLCSP xWave for high frequency wafer probe applications part 2

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Abstract:

Today cmWave(3-30 GHz) and mmWave (30-300 GHz) applications have become mainstream. Packaging has become obsolete and wafers are becoming the new final test package. Testing automotive radar on wafer at 80 GHz and 150 degC was previously a fantasy, but is now a reality. With high power simulation tools and 110 GHz VNA's it's possible to design and fabricate hardware for these extremely high frequency, high temperature applications.

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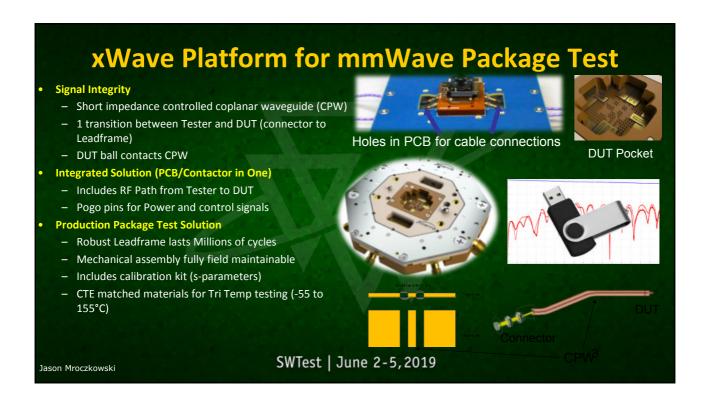


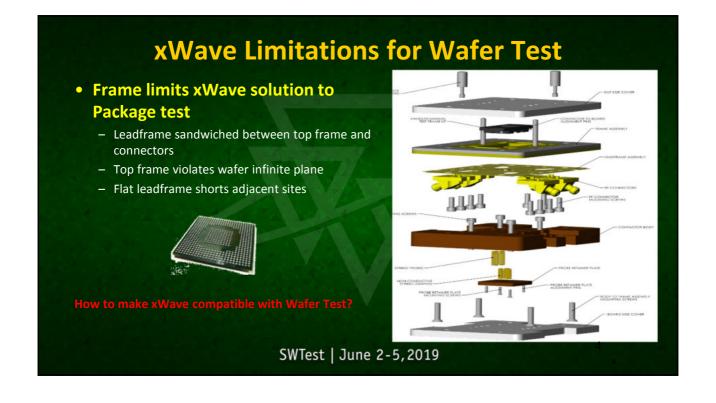
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Overview

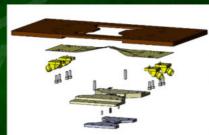
- Objectives / Goals Move from package test to wafer test
- Methods / Materials / Procedures design considerations, mechanical simulation, electrical simulation, characterization
- Results / Relevant Findings / Key Data tip design, force, insertion loss, impedance
- Customer Results/Feedback Initial DC and RF test results
- Summary / Conclusion viable cmWave and mmWave wafer level test solution
- Follow-On Work Beta sites feedback

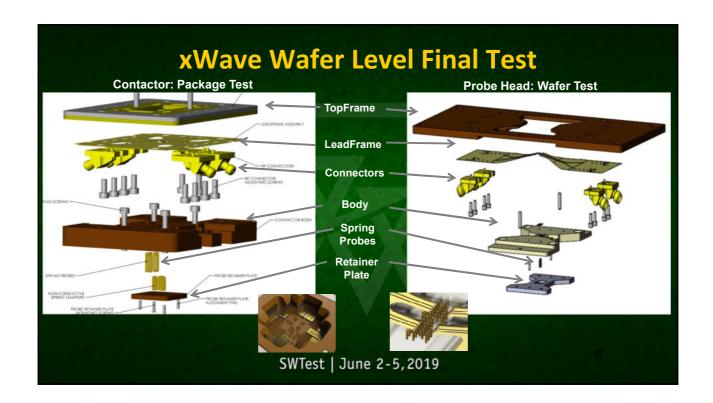




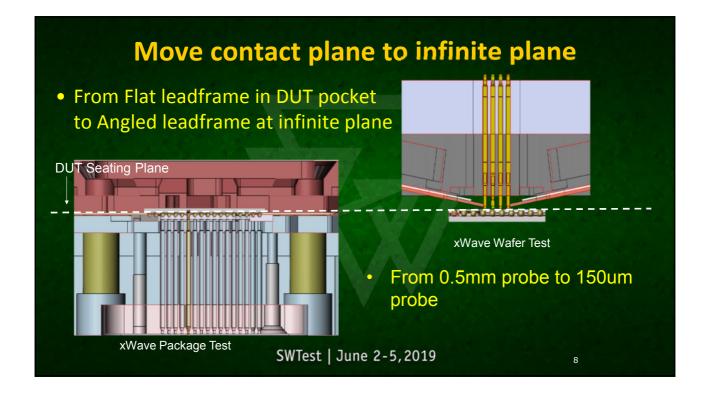
Objectives/Goals

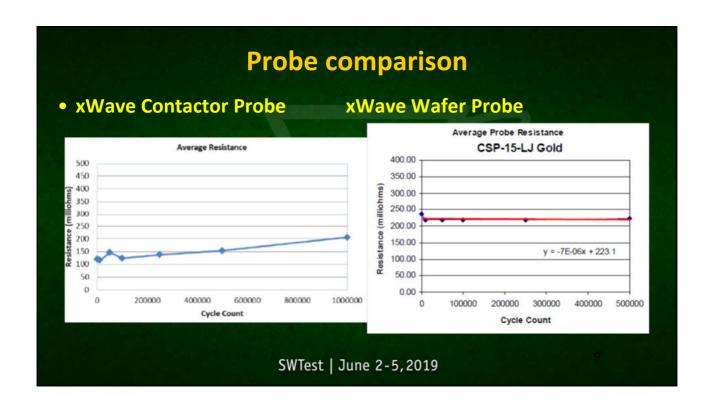
- Move xWave Technology from package test to wafer probe
 - Move contact point of leadframe to infinite plane
 - Combine leadframe with fine pitch pogo technology
 - Reduce leadframe features to match bump pitch
 - Reduce leadframe force to limit contact marking on wafer bumps
 - Limit scrub to ensure no ball shear

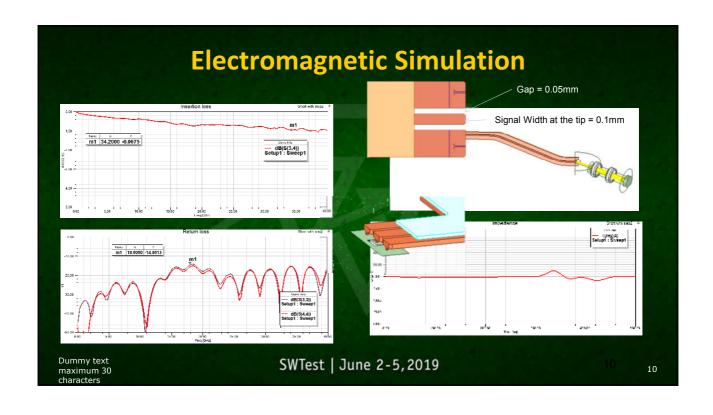


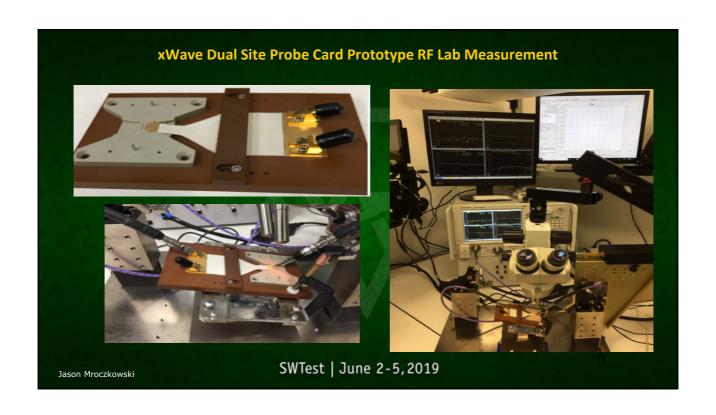


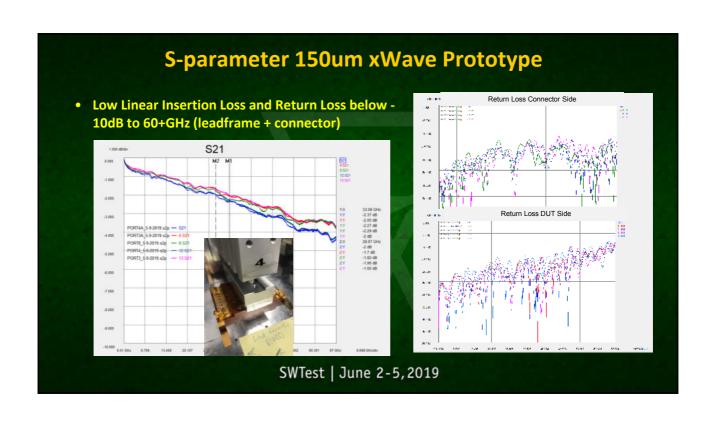


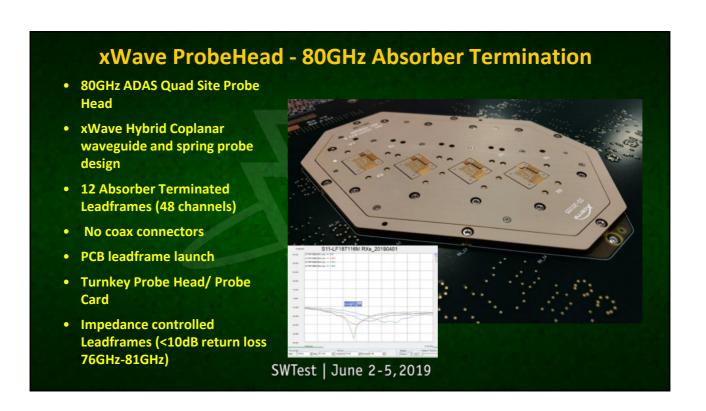


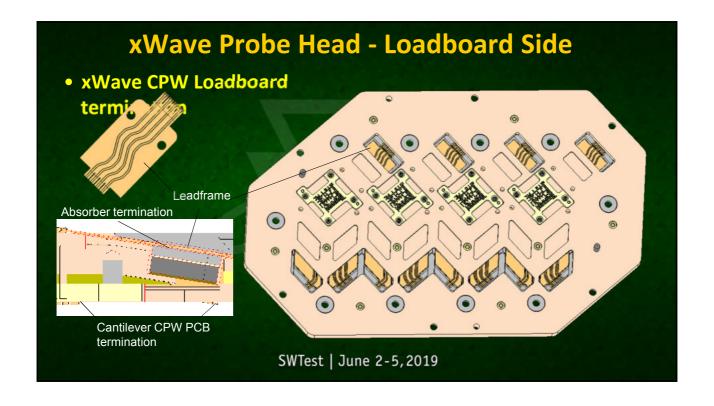


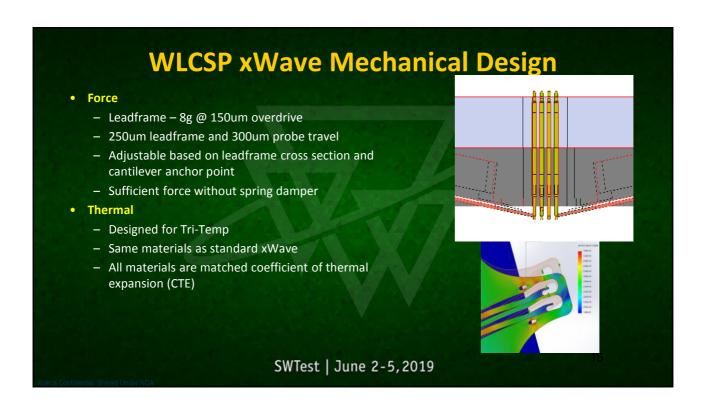


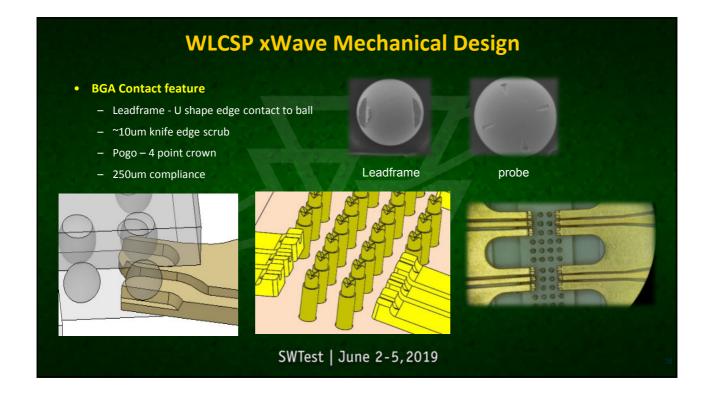


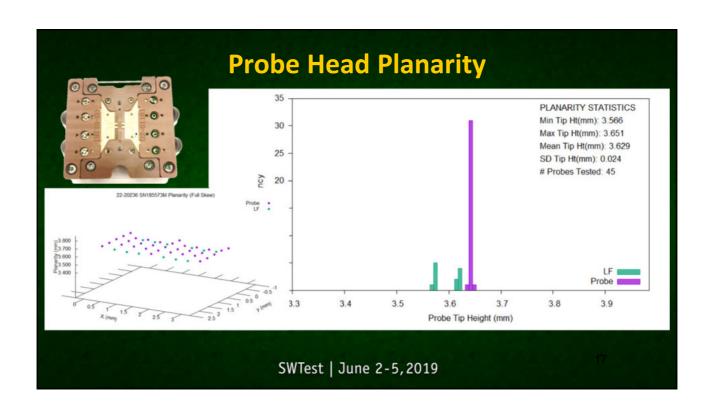








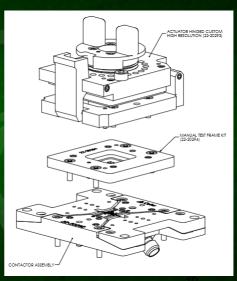


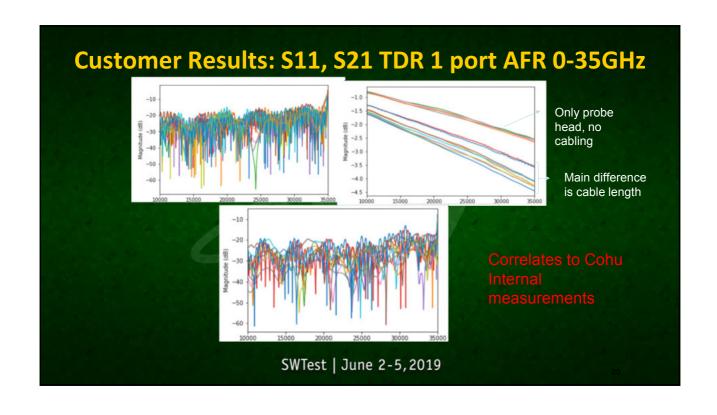




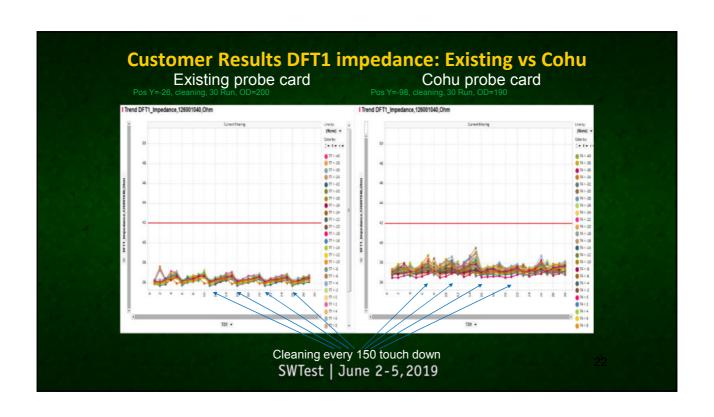
Package Test and Wafer Test in One

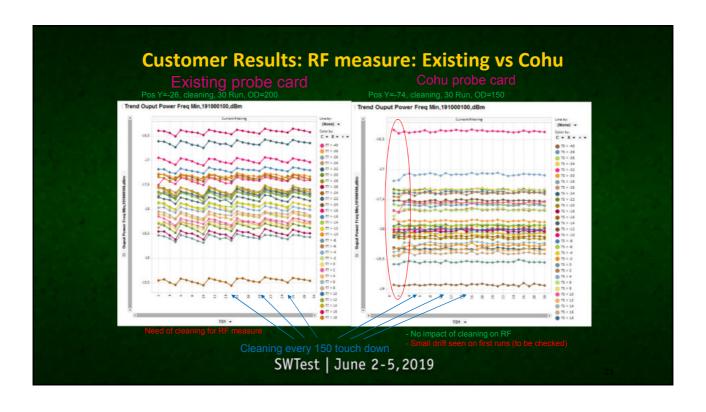
- Same hardware can be used for both packaged test and wafer test
 - Manual Alignment Frame (MAF) attaches to Probe head to convert to final test
 - Manual Actuator (MA) attaches to MAF
 - Simple change over from Wafer to Packaged parts for QA or RMA's

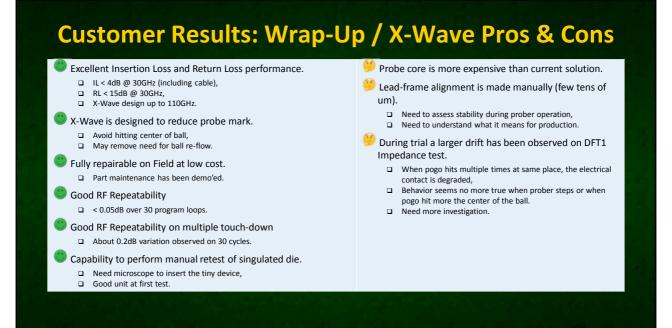




Customer Results: First trials Day 1 Prober setup OK(single only) Site and bump pitch/location is OK DC trials: both sites OK • No overdrive needed to get contact • DC measures analysis on going for different overdrive • No obvious DC probe mark on bump, or very slight (prober camera) - RF trials: site 1 OK • Requires ~100um overdrive to get RF contact - Prober measured 55um difference height DC vs RF Cohu expecting 60um overdrive RF vs DC for contact. Nominal 150um would be ok for most cases. • No obvious RF probe mark on bump, or very slight (prober camera) SWTest | June 2-5,2019







Summary/Conclusion

- Overcame infinite plane and force profile to take the mmWave technology from final test applications to wafer test.
- WLCSP test data shows same electrical and mechanical performance as package test data
- Customer trials shows positive results

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Next Steps

- Improve contrast on Calibration Substrate for better prober visibility
- Move leadframe first contact to same plane as pogo contact
- Standardize on pogo pin length
- Standardize on Leadframe geometry
- Develop internal array contact capability
- Standardize leadframe for lower COT

